			. 	
L Number	Hits	Search Text	ÓВ	Time stamp
1	26335	(((micro or fine or electro adj static or	EPO; JPO;	2003/05/14
-		electrostatic) adj2 (position\$3 or actuation	DERWENT	08:39
		or actuator\$1)) or microactuat\$3 or		30.00
		microposition\$3 or piezo adj2 electric\$1 or		
		piezoelectric or PZT or lead adj zirconium		
		adj titanate or microelectromechanical or		
		MEMS or micro adj electro adj mechanical		
		or bimorph or monomorph or		
		electrostrict\$5) and (g11b\$.ipc. or record\$3		
		or reproduc\$5 or slider or transduc\$5 or		
		dasd or direct adj access adj storage or		
		memory or disk\$1 or disc\$1)		
2	14575	flexure or gimbal	EPO; JPO;	2003/05/14
_			DERWENT	08:39
3	262	((((micro or fine or electro adj static or	EPO; JPO;	2003/05/14
		electrostatic) adj2 (position\$3 or actuation	DERWENT	09:08
		or actuator\$1)) or microactuat\$3 or		33.33
		mlcroposition\$3 or piezo adj2 electric\$1 or		
	ı	piezoelectric or PZT or lead adj zirconium		
		adj titanate or microelectromechanical or		
	ı	MEMS or micro adj electro adj mechanical		
	ı	or bimorph or monomorph or		
	ı	electrostrict\$5) and (g11b\$.ipc. or record\$3		
	ı	or reproduc\$5 or slider or transduc\$5 or		
	ı	dasd or direct adj access adj storage or		
	ı	memory or disk\$1 or disc\$1)) and (flexure		
	ı	or gimbal)		
4	332	(((micro or fine or electro adj static or	IBM_TDB	2003/05/14
		electrostatic or two adj stage or dual) adj2	_	09:13
	i	(position\$3 or actuation or actuator\$1)) or		
		microactuat\$3 or microposition\$3 or piezo		
		adj2 electric\$1 or piezoelectric or PZT or		
		lead adj zirconium adj titanate or		
		microelectromechanical or MEMS or micro		
		adj electro adj mechanical or bimorph or		
		monomorph or electrostrict\$5) and		
		(record\$3 or reproduc\$5 or slider or		
		transduc\$5 or dasd or direct adj access adj		
		storage or memory or disk\$1 or disc\$1)		
5	844	hsa or hga or load adj beam or suspension	IBM_TDB	2003/05/14
		or flexure or glmbal		09:14

7	650	((((mlcro or fine or electro adj static or electrostatic or two adj stage or dual) adj2 (position\$3 or actuation or actuator\$1)) or microactuat\$3 or microposition\$3 or piezo adj2 electric\$1 or piezoelectric or PZT or lead adj zirconium adj titanate or microelectromechanical or MEMS or micro adj electro adj mechanical or blmorph or monomorph or electrostrict\$5) and (record\$3 or reproduc\$5 or slider or transduc\$5 or dasd or direct adj access adj storage or memory or disk\$1 or disc\$1)) and (hsa or hga or load adj beam or suspension or flexure or gimbal) ((((micro or fine or electro adj static or electrostatic or two adj stage or dual) adj2	USPAT;	2003/05/14 09:09 2003/05/14 09:14
		(position\$3 or actuation or actuator\$1)) or microactuat\$3 or microposition\$3 or piezo adj2 electric\$1 or piezoelectric or PZT or lead adj zirconium adj titanate or microelectromechanical or MEMS or micro adj electro adj mechanical or bimorph or monomorph or electrostrict\$5) and (record\$3 or reproduc\$5 or slider or transduc\$5 or dasd or direct adj access adj storage or memory or disk\$1 or disc\$1)).ti.ab.		
8	1354	(ceramic or silicon or hsa or hga or load adj beam or suspension or flexure or gimbal).ti,ab.	IBM_TDB	2003/05/14 09:15
9	101475	(ceramic or silicon or hsa or hga or load adj beam or suspension or flexure or gimbal).ti,ab.	USPAT; US-PGPUB	2003/05/14 09:16
10	111	((((((micro or fine or electro adj static or electrostatic or two adj stage or dual) adj2 (position\$3 or actuation or actuator\$1)) or microactuat\$3 or microposition\$3 or piezo adj2 electric\$1 or piezoelectric or PZT or lead adj zirconlum adj titanate or microelectromechanical or MEMS or micro adj electro adj mechanical or bimorph or monomorph or electrostrict\$5) and (record\$3 or reproduc\$5 or silder or transduc\$5 or dasd or direct adj access adj storage or memory or disk\$1 or disc\$1)).ti.ab.) and ((ceramic or silicon or hsa or hga or load adj beam or suspension or flexure or glmbal).ti,ab.)	USPAT; US-PGPUB	2003/05/14 09:17